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Attorney Docket no. SEL 194

#13/Election/C.
Hawkins
9/19/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Suzawa et al.

Serial No.: 09/615,449

Filed: July 13, 2000

For: Wiring And Manufacturing Method Thereof,
Semiconductor Device Comprising Said
Wiring, And Dry Etching Method

Examiner: H. Trinh

Art Unit: 2814

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Rachelle Hammerquist
Name of applicant, assignee, or Registered Rep.

Rachelle Hamf 8-30-02
Signature Date

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Commissioner for Patents
Washington D.C. 20231

ELECTION AND AMENDMENT C

In response to the Restriction Requirement of August 2, 2002, Applicants elect to prosecute
Species III - figure 15B in the above-identified application. Applicants believe that Claims 12-15,
41-54 and 61-72 are readable on this species.

Applicants are making this election without prejudice to later filing a divisional application
on the non-elected claims and/or species.

09/20/2002 DEVMIS: 00000001 501039 09615449

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IN THE CLAIMS:

Please amend the claims as follows:

C/ 42.(Amended) The semiconductor device according to claim 12, wherein said gate electrode
has an electrical resistivity of 20 $\mu\Omega\cdot\text{cm}$ or less.